

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Group Art Unit: <b>2817</b>
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<b>Koji Naniwada</b>	)	Examiner: <b>Dean O. Takaoka</b>
	)	
Application No. <b>10/595,666</b>	)	Confirmation No.: <b>4359</b>
	)	
Filed: <b>May 3, 2006</b>	)	
	)	
For: MICRO-RESONATOR AND COMMUNICATION	)	
APPARATUS	)	

MAIL STOP AMENDMENT  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

**RE-SUBMISSION OF  
 TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT  
 CITED IN A COMMUNICATION FROM A FOREIGN PATENT OFFICE**

In accordance with the provisions of 37 C.F.R. §§1.56 and 1.98, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form be made during the course of examination of the above-referenced application for United States Letters Patent. The references were cited in an Information Disclosure Statement which was filed on September 18, 2008 with the USPTO. However, one of the references cited did not include a date.

Applicants hereby resubmit a PTO/SB/08a form with the following correction to a Non-Patent Literature Document originally cited on September 18, 2008:

CLARK T.C. NGUYEN, "RF Mems for Wireless Applications," Center for Wireless Integrated Microsystems (WMS), University of Michigan, 2002.

A copy of the Search Report also is enclosed.

Respectfully submitted,

Dated: December 1, 2008

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